Direct Observation at Room Temperature of the Orthorhombic Weyl Semimetal Phase in Thin Epitaxial MoTe 2

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The room temperature observation of the noncentrosymmetric orthorhombic phase of epitaxial MoTe$_2$ on InAs(111) substrate is reported. Due to enlarged lattice parameters of 1–3 ML films a type II topological Weyl semimetal is predicted with Weyl nodes located a few meV below the Fermi level, accessible to transport.

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Direct Observation at Room Temperature of the Orthorhombic Weyl Semimetal Phase in Thin Epitaxial MoTe$_2$
Direct Observation at Room Temperature of the Orthorhombic Weyl Semimetal Phase in Thin Epitaxial MoTe$_2$

Polychronis Tsipas, Sotirios Fragkos, Dimitra Tsoutsou, Carlos Alvarez, Roberto Sant, Gilles Renaud, Hanako Okuno, and Athanasios Dimoulas*

The direct observation at room temperature of the noncentrosymmetric orthorhombic topological Weyl semimetal phase in epitaxial thin films of MoTe$_2$ grown on InAs(111)/Si(111) substrates by molecular beam epitaxy is reported. The orthorhombic phase is typically found at lower temperatures but its observation at room temperature in this work is attributed to the enlarged lattice parameters, influenced by the substrate, which stabilize an interlayer antibonding state compatible with the orthorhombic stacking. First-principles calculations predict eight type II Weyl nodes which are located below (but near) the Fermi energy making them accessible to charge transport and creating the prospect for practical applications exploiting the nontrivial topological properties. The orthorhombic phase coexists with an unconventional triclinic layer stacking which is different than the monoclinic or orthorhombic structures but it is centrosymmetric and topologically trivial.

1. Introduction

2D group VI (Mo,W) transition metal disulphide and dianelurides materials, typically stabilized in the hexagonal 2H prismatic structure, are semiconductors and have been extensively studied due to their great potential for diverse and versatile applications.\cite{1-3} The Mo and W ditellurides (WTe$_2$ and MoTe$_2$) are notable exceptions because structural and electronic instabilities drive a transformation to a lower symmetry, distorted $1T$ (often referred to as $1T'$) octahedral crystal structure with metallic or semimetallic properties.\cite{4}

Moreover, MoTe$_2$ and WTe$_2$ exhibit exciting physical properties adding functionality and significantly extending the range of applications. In the limit of a monolayer with a centrosymmetric structure these materials have been predicted to be 2D topological insulators (or quantum spin Hall insulators)\cite{13} which have been experimentally verified recently for the case of WTe$_2$\cite{14}. In the few layer regime, $1T'$ WTe$_2$ adopts at RT an orthorhombic $Pmn2_1(T_{\gamma})$ phase ($\gamma$-phase) which lacks inversion symmetry thus becoming a topological type II Weyl semimetal as first predicted\cite{15} and later verified\cite{16} for bulk WTe$_2$ material. On the other hand, few layer or bulk $1T'$ MoTe$_2$, at RT is typically found in a centrosymmetric monoclinic $P21/m$ $\beta$-phase which is proposed to be a quantum spin Hall state.\cite{17} However MoTe$_2$ undergoes a structural phase transition from the $\beta$-phase to the noncentrosymmetric orthorhombic ($T_{\gamma}$) $\gamma$-phase at lower temperatures, typically below 250 or 150 K, in which case MoTe$_2$ is predicted\cite{18} to become a type II topological Weyl semimetal (similar to $\gamma$-WTe$_2$), already verified by ARPES in bulk MoTe$_2$.\cite{8,9,19,20} The number of Weyl nodes, their position in $k$-space and energy, and the nature of surface states (topological or trivial) in $\gamma$-MoTe$_2$ depend sensitively on the lattice parameters and the strain. Theoretical values\cite{13} of the lattice parameters differ a lot depending on the density functional used and deviate from experimental values\cite{9,20} which also depend a lot on the fabrication method. Most of the works find 8 Weyl nodes\cite{8,9,18,20,22} while for certain choice of small lattice parameters only 4 Weyl nodes are predicted\cite{23} the
lowest number ever reported for any Weyl semimetal. In all
cases, MoTe₂ Weyl nodes are closer to Fermi energy
(E_F) compared to WTe₂, however they are always
above E_F, including those in Mo₂W₃Te₂, (66,27) thus inhibiting
both their observation by ARPES and their effective use in
functional electronic devices.

To shed light on the electronic structure of γ-MoTe₂ the Weyl
node configuration in particular, and to exploit the topological
properties in practical applications, it is important to control
the lattice parameter and to stabilize the γ-phase of MoTe₂ at
RT by suitable epitaxial methods and substrates. More genera-
larly, the ability to epitaxially grow MoTe₂ thin films by syn-
thetic methods on cm-scale crystalline substrates is essential
to enable device processing. Epitaxial processes are typically
nonequilibrium and are influenced by the substrate so the
most stable structural phases, layer stacking, and physical
properties of epitaxial thin films may be different compared to
those produced by equilibrium bulk methodologies. In most
cases, CVD-grown MoTe₂ thin films are found in the RT most
stable 2H structure although 1T’ structures are also obtained
by postgrowth temperature treatments.[28–30] Growing epitax-
ial thin films of MoTe₂ and WTe₂ by MBE is challenging
because Mo (W) and Te have very similar electronegativities[31]
during coevaporation of Mo (W) and Te, the material tends
to form intermetallic Mo−Mo or W−W bonds which do not
favor the incorporation of Te in the material resulting in poor
Te-deficient and highly nonstoichiometric films. Following the
successful growth of the stable 1T-WTe₂ by MBE on a variety
of 2D substrates by employing interrupted growth method-
ology,[31] a few works[32–34] have reported the stable 2H MoTe₂
phase by MBE but the metastable 1T’ MoTe₂ phase was elusive
until recently when two independent groups[35,36] showed evi-
dence of room temperature 1T’ MBE films mixed with 2H on
epi-graphene/SiC substrates.[35] However, they lack of informa-
tion about the epitaxial quality and the thin film structure; it
is not known in particular whether they adopt the monoclinic
(β-MoTe₂) or orthorhombic (γ-MoTe₂) structure. Stabilization
of the latter Weyl semimetal phase is highly desirable but dif-
ficult to obtain at RT as already mentioned above. An inter-
esting approach is to substitute ~8% of Mo by W to engineer
the γ-phase as it has already been shown using bulk single
crystals.[37] Recently, indirect evidence of RT γ-MoTe₂ has been
reported in thin films exfoliated from bulk where low dimen-
sionality is thought to play a role.[38] Direct observation of the
γ-MoTe₂ phase at RT either on bulk or epitaxial material has
not been reported.

In this paper we report on the direct RT observation of the
important orthorhombic noncentrosymmetric Weyl semimetal
γ-phase in epitaxial 3 ML MoTe₂ films grown layer by layer on
InAs(111)/Si(111) substrates by MBE. Moreover, we observe
an unconventional triclinic layer stacking, which is however
centrosymmetric, topologically predicted to be trivial with no
Weyl points. The measured lattice constants of our epitaxial
orthorhombic phase are found to be notably larger than the
previously reported experimental values from bulk γ-phase
MoTe₂. We argue in this paper that the enlarged lattice param-
eters have important consequences on the energy position of the
Weyl points as well on the stabilization of the γ-phase at room
temperature in epitaxial thin films.

2. Results

2.1. Crystal Structure and Reciprocal Lattice

The structure details and the reciprocal lattice are described
in brief to facilitate the data interpretation. As already men-
tioned, the 1T distorted (1T’) structure of MoTe₂ is typically
found either in the RT monoclinic P2₁/m β-phase or the low
temperature (T < 250 K) orthorhombic (T₂) Pnmn 2γ-phase
(Figure 1). Here we use the notation as follows. 1T’ refers to the
distorted 1T without distinguishing between orthorhombic and
monoclinic stacking. T₂-MoTe₂ refers to orthorhombic stacking
while β-MoTe₂ refers to monoclinic stacking. A characteristic
difference between the two phases is the interatomic distance d
(Figure 1b,c) which becomes larger in the orthorhombic struc-
ture compared to the monoclinic (dₘ > dₐ) due to a parallel shift
of the second (top) layer with respect to the bottom one.[31] The
undistorted 1T lattice can be described either by a primitive
hexagonal unit cell (solid lines in Figure 1d) or by a rectangular
surface nonprimitive unit cell (dashed line) which is double the
hexagonal primitive unit cell (solid line), with lattice parameters
aₚ and bₚ such that aₚ/bₚ = √3. On the other hand, the surface
rectangular primitive unit cell of 1T’ has aₚ/bₚ > √3 deviating
from the “ideal” value of √3. Similarly, the reciprocal space or
1T’ (Figure 1e) has a rectangular primitive unit cell with the
reciprocal lattice constant ratio bₚ*/aₚ* > √3. The deviation of
these ratios from ideal values produces characteristic signatures
in our data as will be discussed below facilitating the nanostruc-
ture characterization of our films.

2.2. Sequential Layer by Layer Thin Film Epitaxial Growth
and Surface Structure

In-terminated InAs(111)/Si(111) substrates are prepared by ex-
situ chemical cleaning followed by in situ thermal annealing
and, where required, by a mild Ar⁺ sputtering (see the Experi-
nental Section) prior to annealing, until a 2 × 2 reconstruction
pattern is obtained in reflection high energy electron diffra-
cion (RHEED) (Figure S1, Supporting Information), indicat-
ing of a clean, oxide-free surface. Thin 1–3 ML MoTe₂ films
are grown (see the Experimental Section) in a layer-by-
layer sequence, with each layer grown in a two-step process. First,
a single layer MoTe₂ is grown at a low temperature of 280 °C
and Te/Mo ratio of 100/1, adopting a beam-interrupted epitaxy
method similar to that used for the MBE growth of WTe₂.[31]
After 30 s of W and Te co deposition, the growth is interrupted
by closing the Mo shutter for about 60 s, while the film is con-
tinuously exposed to Te and then the growth continues again
by opening the Mo shutter for another 30 s. The process is
repeated until 1 ML of MoTe₂ is completed. The growth rate
is estimated to be 0.5 ML min⁻¹. Subsequently, the sample is
annealed at 400 °C in the presence of Te flux (0.5 Å s⁻¹) for
30 min to improve the crystallinity and the surface ordering
monitored by RHEED (Figure S1, Supporting Information).
Once the first layer is fully formed and optimized, the second
and third layers are grown by repeating the same process, thus
enabling the sequential layer-by-layer growth of MoTe₂ thin
films.
The surface nanostructure of 1 ML 1T' MoTe₂ is imaged in Figure 2a by in-situ ultrahigh vacuum scanning tunneling microscopy (UHV-STM) at RT. The domains have an average lateral size ≈40 nm and they differ in height about 3.5 Å (Figure 2b), which is the same as the height of monatomic steps of the underlying InAs substrate. It is therefore concluded that the domain formation in MoTe₂ originates from the monatomic step nanostructure of the InAs surface, consistent with scanning transmission electron microscopy (STEM) observations shown in subsequent section (Figure 3).

Deposition of a second layer results in the formation of 2D islands (Figure 2c) with a height of ≈7 Å (Figure 2d) which is roughly equal to the thickness of a single 1T' MoTe₂ layer including the van der Waals gap between the top and the bottom layers. The islands coalesce to form a complete second layer.

Atomic resolution STM images of a single domain are consistent with the symmetry of 1T' MoTe₂ surface (Figure 2e). The Fourier transform in Figure 2f yields the surface reciprocal space in similarity with the schematic of Figure 1f. In a different part of the surface, two domains A and B rotated 60° with each other are imaged (Figure 2g) resulting in a more complex reciprocal space (see the Fourier transform of Figure 2h) where additional periodicities (1 and 2 in Figure 2h), define a reciprocal lattice for domain B (white dashed rectangles) rotated by 60° with respect to the one corresponding to domain A (red dashed rectangles). Consideration of the complex reciprocal space composed of superimposed rotated lattices is essential.
for the interpretation of X-ray diffraction (XRD), angle resolved photoelectron spectroscopy (ARPES) and RHEED measurements reported in the subsequent sections and the Supporting Information.

2.3. Orthorhombic and Unconventional Triclinic Layer Stacking Structure

The MoTe₂ thin films are evaluated in cross-section by STEM at RT to identify the film layer stacking. Figure 3 shows cross-section images for both 1 and 3 ML MoTe₂. In Figure 3a, two regions of 1 ML of 1T′ MoTe₂ are shown interrupted by an atomic step in the InAs, ≈3.5 Å, hence forming domains with different heights, similar to STM observations in Figure 2a. It is worth mentioning that there is no evidence for the 2H prismatic phase which is the most stable at RT, therefore the thin films are in a pure 1T′ phase.

As the growth continues from 1 to 3 ML 1T′ MoTe₂, two dominant phases are observed, namely the orthorhombic T₉-MoTe₂ phase (Figure 3c), comprising two layers in the unit cell, which typically appears at lower temperatures (<250 K) and an unconventional triclinic stacking, containing one layer per unit cell (Figure 3e), not previously reported. A fundamental difference between the triclinic stacking of Figure 3e and the conventional room temperature stable β-MoTe₂ monoclinic phase is that the second layer is rotated by 180° with respect to the first layer. The lattice parameter along the c-axis in the T₉ orthorhombic structure (Figure 3b,c) is measured to be between 14.1 and 14.2 Å (Figure 3d), which is significantly larger than the reported experimental c values from bulk T₉-MoTe₂ crystals[6–9] found to be in the range between 13.861 and 13.8935 Å. Moreover, among the different 1T′ structures (Figure 1), the most stable room temperature monoclinic stacking, known as β-MoTe₂ (Figure 1c) is absent in our films. Additionally, fast Fourier transform (FFT) patterns were calculated from the regions containing only the MoTe₂ film in the STEM images; they are shown in Figure 3f–h. The FFT patterns were analyzed and compared with corresponding simulated electron diffraction patterns to verify the different MoTe₂ crystals structures. The simulated electron diffractions patterns and this analysis are presented in Figure S3 of the Supporting Information.
2.4. In-Plane Epitaxial Orientation and Rotated Domain Microstructure Investigated by Synchrotron Grazing Incidence X-Ray Diffraction (GIXD)

Single-layer and three-layer MoTe$_2$ are evaluated by GIXD and the data for 3 ML films are presented in Figure 4. The in-plane reciprocal space map (RSM) in Figure 4a reveals that the MoTe$_2$ film is epitaxially grown on InAs in such a way that [100] MoTe$_2$//[11-2]InAs, and [010] MoTe$_2$//[01-1]InAs in the plane. We observe no 30° or 90° rotated domains or polycrystallinity other than that arising from the Al protecting cap (rings in Figure 4a). The positions of the diffraction peaks in $k$-space are in agreement with those predicted for the epitaxial growth.

Figure 3. STEM images from epitaxial MoTe$_2$ thin films. a) 1 ML of 1T'-MoTe$_2$ showing film interruption at the edge of an InAs monoatomic step b) 3 ML 1T' phase along [1100] zone axis, c) 3 ML orthorhombic (T$_d$) stacking along [1120] zone axis, d) intensity line plot in the c direction from images (b) and (c) in red and green, respectively, e) 3 ML of unconventional triclinic stacking along [1120] zone axis, f–h) FFT patterns from respective STEM images. The equivalent [uvw] notation for the zone axis directions are [100] for [1100], and [010] for [1120].
with a complex reciprocal space (open circles in Figure 4a) which is a superposition from 0°, 60°, and 120° rotated domains. The most characteristic configuration is the triplet along $h = k$ ([01-1]$_{\text{InAs}}$) consisting of the on-axis (020) peak and the two off-axis (310) peaks all belonging to different domains rotated between each other by 60°. It should be noted that in the ideal case where $b/a = \sqrt{3}$ applying to the hexagonal symmetry of the undistorted 1T structure (see Figure 1d), all three closely spaced reciprocal lattice points would be expected to coincide giving a single diffraction peak. In our case though of a distorted 1T MoTe$_2$ lattice, where the ratio deviates from ideal ($b/a > \sqrt{3}$), the peak splitting into a triplet configuration is clearly detected by GIXD (Figure 4a). Similar situation arises along $h$ ([11-2]$_{\text{InAs}}$) direction with the triplet consisting of...
the on-axis (400) peak and two off-axis (220) peaks from rotated domains as well as the triplet involving (200) and two (110) peaks although the latter triplet is not resolved very well. As a consequence, the radial scans along $h$ and $k = \pm k$ directions in Figure 4b show doublets for certain diffractions.

In the doublet the peak due to the off axis signals superposition have larger transversal width as seen from the rocking curves of Figure 4c and d because they have the contributions from two off-axis diffraction peaks (see the deconvolution of (310) diffraction peak in Figure 3d). From the FWHM of the on-line single peak (020) in Figure 3c an in-plane mosaicity of 3.71° is estimated which is substantially higher than that of the InAs substrate (0.79°); also higher than the mosaicity of 1.79° observed in epitaxial ZrTe$_2$ on InAs(111) substrate.$^{[39]}$

Considering only the well resolved on-axis single peaks (020), (300), and (400), the reciprocal $(a^*, b^*)$ and direct $(a, b)$ lattice parameters can be accurately determined from the RSM and the radial scans as follows. The position of the 020 peak in the q space is $q = 3.5894$ Å$^{-1}$ and it is equal to two times the reciprocal space unit cell constant $b$ (Figure 4b). Therefore $b^* = q/2 = 1.7947$ Å$^{-1}$ and $b = 2\pi/b^* = 3.501$ (±0.003) Å. Looking along the $h$ and $k$ directions in Figure 4a, the (300) and (400) peaks are $3a^*$ and $4a^*$, respectively, and by considering their location in $k$-space from Figure 4b, $a^* = 0.99105$ Å$^{-1}$ (averaged over the four peaks, two along each direction $h$ and $k$) and $a = 2\pi/a^* = 6.340$ (±0.005) Å are obtained. These values are in reasonably good agreement with the ones deduced from RHEED (Figure S1, Supporting Information).

It is worth noting that the values $a$, $b$ (determined from GIXD) and $c$ (determined from STEM) in our epitaxial thin films are larger than the ones measured from bulk T$_d$-MoTe$_2$ crystals.$^{[6–9]}$ This is attributed to the influence of the substrate and the layer-by-layer sequential growth adopted in the present work.

2.5. Electronic Band Structure of 1T’ MoTe$_2$ Epitaxial Thin Films

The electronic band structure of 1 ML 1T’ MoTe$_2$ imaged by in situ ARPES is given in Figure 5, in direct comparison with 1 ML density functional theory (DFT) first-principles calculations using the experimental lattice parameters deduced from our epitaxial thin films. In contrast to exfoliated single crystal 1T’ MoTe$_2$, our epitaxial material contains rotated domains differing by 60° between each other (see also discussion of STEM, XRD, and RHEED in Figures 2 and 4 and Figure S1, Supporting Information). This gives rise to a complex Brillouin zone (BZ) configuration (Figure 5d) resulting in an overlap of the electronic band structure along two different directions in the BZ, as for example $\Gamma Y$ and $\Gamma S$ directions, in the ARPES spectrum of Figure 5a, yielding a complex dispersion adversely impacting energy and momentum resolution. By employing second derivative of the energy dispersion the resolution is improved (Figure 5b,c) yielding a reasonably good agreement with DFT simulations along the high symmetry lines in the BZ which are indicated by thick (blue and red) arrows in Figure 5d. Notably, the feature at around $k_{yz} = 1$ Å$^{-1}$ in Figure 5b is located at the $\Gamma$ point of the neighboring BZ (indicated by broken line in Figure 5d) and is effectively a replica of the band at $k_{yz} = 0$ Å$^{-1}$.

There is also evidence for the existence of electron pockets near the $\Gamma$ point along $\Gamma X$ as predicted by DFT in Figure 5c (blue line).

In principle, by applying ARPES to thicker films, it should be possible to distinguish between orthorhombic T$_d$-phase and triclinic stacking and therefore identify the most dominant configuration however the ARPES spectra for 2 and 3 ML (not shown here) are very similar to the ones for 1 ML (Figure 5).

This could be explained by considering that 21.22 eV ARPES known to be a surface sensitive technique probes the topmost layer which is coupled weakly to the bottom layers showing the behavior of a single layer in ARPES.

Using the measured set of lattice parameters in our epitaxial thin films ($a = 6.340$ Å, $b = 3.501$ Å, $c = 14.15$ Å) we have performed DFT bulk band structure calculations for the noncentrosymmetric orthorhombic (T$_d$) structure with the aim to predict the existence of Weyl nodes and find their location in energy and k-space. By considering the topmost valence band and the next (conduction) band we find eight Weyl nodes as a result of broken inversion symmetry (Figure 6), which are all located in the $k_z = 0$ plane and are symmetrically placed in k-space with respect to the high symmetry directions X–Γ–Y and Y–Γ–Y as shown in the schematic of Figure 6a. Their exact coordinates in $k$-space and energy are as follows: $W_1^-$: $(k_x = 0.1807$ Å$^{-1}, k_y = 0.0456$ Å$^{-1}, k_z = 0$ Å$^{-1})$ at $E-E_F = -1.1$ meV, $W_2^-$: $(k_x = 0.1871$ Å$^{-1}, k_y = 0.0351$ Å$^{-1}, k_z = 0$ Å$^{-1})$ at $E-E_F = -12.9$ meV.

The Weyl nodes in each pair have opposite chirality and are located below the Fermi level but very close to it (Figure 6b). The Fermi arc connecting the Weyl nodes with opposite chirality (+, –) is shown as part of the surface state passing through them in Figure 6b. It should be noted that this set of lattice parameters deduced from our epitaxial thin films yields Weyl nodes which are closer to the Fermi level than any other reported.$^{[8,9,18,20,23,24]}$ Weyl nodes for MoTe$_2$ in the literature. While in all of these cases, they are typically located a few tens of meV above $E_F$ in our epitaxial thin films the Weyl nodes are predicted just below the Fermi level which facilitates observations by ARPES and makes them accessible to transport, thus suitable for electronic applications where topological properties can play a critical role.

The unconventional triclinic layer stacking as evidenced by STEM in Figure 3d, yields a calculated bulk band structure (Figure S4, Supporting Information) with no Weyl points, a result which is expected since this structure is centrosymmetric.

To gain more insight about the possible role of the enlarged lattice parameters on the stabilization of the orthorhombic T$_d$-phase at room temperature in our epitaxial thin films we analyze our first-principles calculations which have been performed using two different sets of experimental lattice parameters (Figure 7) following similar methodology and reasoning as in ref. [21] Set #1 ($a = 6.3341$ Å, $b = 3.4751$ Å, $c = 13.8816$ Å) in Figure 7a is an average obtained from experimentally reported values for bulk, free standing T$_d$-MoTe$_2$.$^{[6–9]}$ detected at low temperatures and Set #2 ($a = 6.340$ Å, $b = 3.501$ Å, $c = 14.15$ Å) in Figure 7b is from our measured T$_d$-MoTe$_2$ epitaxial films at RT. In both band structures (Figure 7a,b), the uppermost valence band B1 along $\Gamma A$ consists of hybridized Te $p_x$ and Mo $d_{xz}$ orbitals while the lower band B2 consists of hybridized Te $p_y$ and Mo $d_{yz}$ orbitals. From the plot of the wavefunctions of B1 and B2 at $\Gamma$ for Set #2 (our experimental
parameters) in Figures 7c,d, it is inferred that interlayer coupling occurs through an antibonding configuration along an elongated interlayer distance $d$ (Figure 7c). This elongation stabilizes $T_d$ stacking configuration at RT since $d(=d_o)$ for orthorhombic stacking is large and indeed larger than the corresponding monoclinic distance $d_m$ (see Figure 1b,c).

3. Discussion

In this work we use MBE to grow the distorted 1T (1T') phase of MoTe$_2$ epitaxially on InAs(111)/Si(111) substrates. Adopting an interrupted growth methodology at low growth temperatures ($\approx$280 °C) first applied to the MBE growth of WTe$_2$ on MoS$_2$ and HOPG substrates, we show by STEM and GIXD that a...
Calculated Weyl node configuration for the bulk orthorhombic $T_d$-MoTe$_2$ using the experimental parameter sets deduced from our epitaxial films. a) Positions of Weyl nodes in the first Brillouin zone. The blue and red points closely spaced between each other indicate pair of Weyl nodes with opposite chirality. b) Theoretical energy dispersion along a path KK' shown by broken line in (a), passing through the pair of Weyl points. Theoretical constant energy contour plots for two different energies c) $E = -1.1$ meV and d) $E = -12.9$ meV corresponding to the energy location of the Weyl node pairs. $e^-$ and $h^+$ denote the touching electron and hole pockets, respectively.

Figure 6. Calculated Weyl node configuration for the bulk orthorhombic $T_d$-MoTe$_2$, using the experimental parameter sets deduced from our epitaxial films. a) Positions of Weyl nodes in the first Brillouin zone. The blue and red points closely spaced between each other indicate pair of Weyl nodes with opposite chirality. b) Theoretical energy dispersion along a path KK' shown by broken line in (a), passing through the pair of Weyl points. Theoretical constant energy contour plots for two different energies c) $E = -1.1$ meV and d) $E = -12.9$ meV corresponding to the energy location of the Weyl node pairs. $e^-$ and $h^+$ denote the touching electron and hole pockets, respectively.

pure 1T' MoTe$_2$ phase can be obtained with improved crystallinity after postgrowth annealing at 400 °C. Despite the fact the 2H prismatic phase of MoTe$_2$ is more stable at RT, a pure 1T' MoTe$_2$ phase is observed here attributed to the influence of the substrate due to tensile biaxial strain and/or electron doping. Tensile strain between 0.3% and 3% under uniaxial conditions as theoretically predicted or 0.2% as experimentally demonstrated [11] is thought to drive the transition from the stable 2H to the metastable 1T' MoTe$_2$ phase at or near RT. In our case, the in-plane $a$ and $b$ lattice parameters of the epitaxial films are accurately measured by synchrotron GIXD (Figure 4) and found to be larger than those obtained in free standing films exfoliated from bulk [6,9], indicating a relatively small epitaxial tensile strain configuration with $\varepsilon_{xx} = \Delta a/a = +0.1\%$ and $\varepsilon_{yy} = \Delta b/b = +0.7\%$, which may partly explain the transformation to 1T' phase at RT in our epitaxial thin films. It has also been predicted [17] that electron doping $\approx 0.1e^-/\text{unit cell}$ induces the $2H \rightarrow 1T'$ transition in MoTe$_2$. Electron doping could be a possible scenario in our case, since the electronic charge can be provided by the InAs substrate which is known to have strong n-type semiconductor character at the surface due to the accumulation of a dense electron gas. [40]

MBE, a typically far from equilibrium process, can produce thin film structures which cannot be obtained under equilibrium conditions. Beyond the substrate effects (strain, doping) already discussed above, the ability to sequentially grow one layer on top of another as in the present work, allows different stacking configurations which cannot be obtained in films exfoliated from bulk. Such a layer stacking, namely a triclinic structure is observed here by STEM (Figure 3e; Figure S2, Supporting Information), where all layers are in phase presenting a fundamental difference compared to the typical monoclinic or orthorhombic structures where two consecutive layers are 180° out of phase (Figure 1). Hints of such in-phase layer stacking are found also in MBE-grown WTe$_2$ [31] but not sufficiently emphasized. Although the triclinic structure is noncentrosymmetric with trivial topology (no Weyl nodes found), it is very interesting that here the important noncentrosymmetric orthorhombic ($T_d$) Weyl semimetal phase is observed by STEM coexisting with the triclinic structure. This orthorhombic phase is typically reported in the literature below 250 or 150 K so questions are raised about the possible origin of its stability at RT as observed in our work. The reduced dimensionality analysis previously proposed to explain the indirect observation [38] of RT $T_d$-MoTe$_2$ in 12 nm thick films exfoliated from bulk does not directly apply to our ultrathin (1–3 ML) films. Our DFT analysis for $T_d$-MoTe$_2$ (Figure 7) shows that the enlarged lattice parameters of our epitaxial thin films result in a characteristic band structure where the uppermost valence band B along $\Gamma A$ is fully occupied dispersing well below the Fermi level similar to what is observed for $T_d$-WTe$_2$. [21] It should be noted that in the case of $T_d$-WTe$_2$, the full occupation of this band is correlated with the absence of a barrier in the energy profile for the transition from $\beta$ to $T_d$-phase [21] which explains the stability of $T_d$-phase at RT. A similar situation could apply for the epitaxial MoTe$_2$ in this paper. Expressing it in a different way, it...
the enlarged lattice parameters in the epitaxial thin films could explain the observation at RT of the orthorhombic $T_d$-MoTe$_2$ instead of the monoclinic phase.

The RT orthorhombic MoTe$_2$ reported here lacks inversion symmetry so it is expected to be a topological Weyl semimetal. Using the enlarged experimental lattice parameters found in this work, a DFT analysis (Figure 6) for the $T_d$-MoTe$_2$ predicts eight type II Weyl nodes which are located very close to the Fermi level and just below it, in notable difference with previous results where all Weyl points were found above $E_F$. The occupation of states near the Weyl nodes makes them visible in ARPES electronic band imaging and accessible to transport which means that epitaxial thin films of $T_d$-MoTe$_2$ on InAs(111) substrates can be used to fabricate devices which could exploit the nontrivial topological properties of these films in practical RT applications.

Future work should focus on improving the epitaxial quality of these films. Although there is a very good in-plane epitaxial alignment between MoTe$_2$ and InAs substrate such that $[100]_{\text{MoTe}_2}//[11-2]_{\text{InAs}}$ and $[010]_{\text{MoTe}_2}//[01-1]_{\text{InAs}}$ (Figure 4), with no signs of polycrystallinity, the in-plane mosaicity of $3.71^\circ$ is substantially higher than the InAs one ($0.79^\circ$) and higher than the 1.79$^\circ$ mosaicity of epitaxial ZrTe$_2$ on InAs.$^{[9]}$ Moreover, the MoTe$_2$ epilayer, similar to the case of ZrTe$_2$,$^{[9]}$ follows the landscape of the InAs surface (STEM in Figure 3) which shows monatomic steps of 3.5 Å, producing a MoTe$_2$ nanostructure with domain size in the order of a few tens of nm as also seen by STM in Figure 2. The presence of 60$^\circ$ and 120$^\circ$ rotated domains is widely evidenced by STM, RHEED, and GIXD data, which is a distinct characteristic of our thin epitaxial films compared to single crystals obtained from bulk where such domains are absent. While these rotated domains in the hexagonal undistorted 1T or 2H MoTe$_2$ structure are equivalent, in $T_d$-MoTe$_2$ result in a complex $k$-space and Brillouin zone, mixing the energy dispersion along different directions thus adversely affecting resolution, inhibiting clear observation of Weyl node configuration in ARPES. Domain rotation may be facilitated at the step edges, where also the continuity of the film may be interrupted (Figure 3), which could be harmful for electrical transport. By improving the surface treatment of InAs prior to growth we might be able to minimize the density of monatomic steps and increase the domain size in an attempt to obtain a single crystalline epitaxial film. Although the use of single crystal InAs(111) could resolve some of the issues related to the step and domain formation and improve the mosaicity of MoTe$_2$, the effort should focus on the improvement of epitaxial InAs on Si substrates since the availability of large area wafers (200 and 300 mm) of this kind is essential for a manufacturable technology of MoTe$_2$ and other 2D materials in the future.

### 4. Conclusion

In this work epitaxial thin films of MoTe$_2$ with the distorted 1T' structure are grown by molecular beam epitaxy on InAs(111)/Si(111) substrates. The films are rotationally commensurate with the substrate such that [100]$_{\text{MoTe}_2}//[11-2]_{\text{InAs}}$ and [010]$_{\text{MoTe}_2}//[01-1]_{\text{InAs}}$ although 60$^\circ$ and 120$^\circ$ rotational domains are present, detected by STM, synchrotron GIXD, and RHEED.

Figure 7. DFT calculations for bulk $T_d$-MoTe$_2$ for two different lattice parameter sets: a) averaged experimental lattice parameters from bulk $T_d$-MoTe$_2$ taken from refs. [6–9], b) experimental lattice parameters from epitaxial thin films in this work. The symbols in both (a) and (b) represent the projections of the bands in the Te and Mo orbitals. c,d) Wavefunctions at the $\Gamma$ point are plotted for valence bands B1 and B2, respectively, corresponding to $T_d$-MoTe$_2$ calculated with the experimental parameters reported in this work (Set #2). The wavefunction sign (+) and (−) is indicated by blue and green color, respectively.

can be said that this fully occupied band B (Figure 7) is related to an antibonding state$^{[21]}$ along the interlayer distance $d$ (see Figure 1), then the $T_d$-MoTe$_2$ is favored because this phase is compatible with an enlarged $d$ ($d_o > d_m$ in Figure 1) as it would be expected for an antibonding state. This analysis shows that
Using STEM cross-sectional measurements in 3 ML MoTe₂ we identify two different phases coexisting in the layer. The first phase shows an orthorhombic (Tₐ) stacking (or γ-MoTe₂) and the second phase is a triclinic stacking not reported before. From GIXD and STEM we measure lattice parameters values a = 6.340 Å, b = 3.501 Å and out of plane parameter for the orthorhombic Tₐ-phase c = 14.1–14.2 Å which are larger compared to freestanding thin films exfoliated from bulk as a result of the influence from the substrate.

The MoTe₂ orthorhombic Tₐ-phase typically found at temperatures lower than 250 K, here is observed at room temperature which is attributed to an interlayer antibonding state compatible with the orthorhombic Tₐ-phase as a result of the enlarged lattice parameters of our epitaxial thin films. The orthorhombic Tₐ-MoTe₂ is noncentrosymmetric yielding a topological type II Weyl semimetal phase. Eight Weyl nodes calculated by DFT are few meV below the Fermi level are accessible to transport creating the prospect for room temperature electronic applications where the topologically nontrivial properties of MoTe₂ epitaxial layers could play a role.

5. Experimental Section

Surface Preparation and Film Growth Details: The InAs(111)/Si(111) substrates were chemically cleaned in a 5% HF solution in isopropanol alcohol for 5 min to etch the surface oxide and subsequently rinsed in isopropanol alcohol for 30 s in order to avoid reoxidation of the substrate. An annealing step at 400 °C in UHV follows to get a clean and flat InAs(111) surface as evidenced by RHEED (Figure S1, Supporting Information) and X-ray photoelectron spectroscopy. Where appropriate, mild Ar⁺ sputtering was used (E = 1.5 keV, p = 2 × 10⁻⁵ mbar, t = 30 s) prior the annealing step to obtain a clean surface as evidenced by a 2 × 2 reconstruction in RHEED pattern (Figure S1a,b, Supporting Information) attributed to In surface vacancies.[41]

ARPES Measurements: In-situ ARPES was conducted at room temperature in a μ-metal analytical chamber equipped with a 100 mm hemispherical electron analyzer (SPECs PHOIBOS 100) and a 2D CCD detector. The energy resolution of the detection system was better than 40 meV using a 21.22 eV photons from a He discharge source (SPECs UVS35[10]), although, since the measurement is performed at RT, the resolution is limited by thermal effects and is about 100 meV.

STM Characterization: After MoTe₂ films growth, the samples were transferred to the STM (OMICRON) chamber without breaking the vacuum for in situ STM characterization. STM images were obtained in UHV conditions (base pressure = 10⁻⁹ mbar) at room temperature using a Pt/Ir tip at the following conditions: V = 0.1 mV, I = 1 nA for the rest resolution images (Figure 2e–h) and V = 0.4 mV, I = 400 pA for the STM characterization. STEM measurements have been carried out using a Cs-corrected FEI Themis at 200 keV. HAADF-STEM images were acquired using a convergence semiangle of 18 mrad and collecting scattering >5 mrad. STEM specimens were prepared by the FIB lift-out technique using an FEI dual-beam Strata 4005 at 30 kV.

Synchrotron GIXD Measurements: Diffraction measurements were performed at the European Synchrotron Radiation Facility by means of the UHV-MBE CVD diffractometer installed at the BM32 CRC/IF beamline and optimized for GIXD. The experimental setup energy and incident angle were set at 11 keV (1.13) and 0.2°, the latter set slightly below the critical angle value for total reflection in order to enhance the 2D film signal while minimizing the background.

First-Principles Calculations: The first-principles calculations were performed using the Vienna Ab initio Simulation Package[42,43] and projector-augmented wave.[44] The generalized-gradient approximation with Perdew–Burke–Ernzerhof[45] parameterization was used as exchange correlation functional. The kinetic energy cutoff was set at 450 eV, using the Monkhorst–Pack scheme[46] employing a 12 × 10 × 6 k-point mesh for bulk calculations. The experimental lattice constants were used and the atomic positions were fully optimized by conjugate gradient, using a force threshold of 1 × 10⁻⁴ eV Å⁻¹. Van der Waals corrections were used by applying the semiempirical DFT-D3 Grimme’s method.[47] The Maximally-Localized Wannier functions are fitted based on Mo’s s and d and Te’s p orbitals using the Wannier90 code[48] and the surface states, topological Fermi arcs, and Weyl points calculations were carried out by the WannierTools software.[49] Spin–orbit coupling was included in band structure calculations.

Supporting Information

Supporting Information is available from the Wiley Online Library or from the author.

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Conflict of Interest

The authors declare no conflict of interest.

Keywords

2D materials, molecular beam epitaxy, orthorhombic MoTe₂, transmission electron microscopy, Weyl semimetal

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